

10822064 - GAU:

PTO/SB/08A (08-03)

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Sheet 1 of 2

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Application Number	10/822064
Filing Date	Apr 8, 2004
First Named Inventor	Neal W. Meyer
Art Unit	
Examiner Name	unassigned
Attorney Docket Number	200312670-1

Attorney Docket Number 200312670-1

U. S. PATENT DOCUMENTS

2/23/10

FOREIGN PATENT DOCUMENTS

Examiner (Printed Name) _____ Date _____

Signature /Rick Chang/ Considered 11/25/2007

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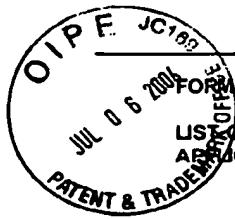
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JUL 6 2004 FORM PTO-1449

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S INFORMATION DISCLOSURE
STATEMENT

(Use several sheets if necessary)

ATTY. DOCKET NO.	APPLICATION NO.	CONFIRMATION NO.
200312670-1	10/822,064	
APPLICANT		
Meyer, et al.		
FILING DATE	GROUP	
04/08/2004		

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME	Pages, Columns, Lines Where Relevant Passages or Figures Appear
/RC/	1A 6284072	09/04/2001	Ryan, et al.	
	1B 6348999	02/19/2002	Summersgill, et al.	
↓	1C 5985084	11/16/1999	Summersgill, et al. 65	
	1D 6517995	02/11/2003	Jacobson, et al.	
/RC/	1E 6341190	01/22/2002	Summersgill, et al.	
	1F			
	1G			
	1H			
	1I			
	1J			
	1K			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	PUBLICATION DATE	NAME OF PATENTEE OR APPLICANT	Pages/Columns/Lines Where Relevant Passages/Figures Appear	Check if Translation attached
/RC/	1L	WO96/35971	11/14/1996	Epigem Limited	WO 9635971	
/RC/	1M	WO01/11591	02/15/2001	Epigem Limited		
/RC/	1N	WO98/21626	05/22/1998	Epigem Limited		
	1O					
	1P					

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

/RC/	1Q	"High-resolution soft lithography"; IBM Zurich Research Laboratory, Science & Technology, Microcontact processing; http://www.zurich.ibm.com/st/microcontact/highres/ .
/RC/	1R	"Replica Molding (REM)"; Lithotemplate.html.; http://www.ee.washington.edu/research/microtech/cam/CAMreplicamolding.html.
/RC/	1S	SCHWARTZ; "Numerical modeling of liquid withdrawal from gravure cavities in coating operations; the effect of cell pattern"; Journal of Engineering Mathematics 42: 243-253, 2002;

EXAMINER

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